

## Thermal Contact Conductance in Vacuum Euspen SIG on Thermal Issues; March 22 & 23, 2022

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#### Introduction

## Philips Engineering Solutions

- Philips Engineering Solutions
  - Originated from Philips CFT, Apptech, Innovation Services, ...
  - "Creates the bridge from idea to market"
  - Innovation support to both Philips businesses as external partners
  - Head quartered in Eindhoven (High Tech Campus)
- Rob van Gils
  - 2002 2012: Master/PhD at TU/e, Dynamics and Control
    - Control of a Pool-boiling system
    - Connection between Dynamics, Control and Thermal field
  - 2012 2022: Sr. Technologist at Philips Engineering Solutions
    - Competence Leader Thermal & Flow
    - Bridge gap between thermal field and other mechatronics competences







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### Motivation

- Thermal Contact Conductance (TCC): the thermal resistance between two solids that are pressed together
  - Literature: multiple application areas, see [Yovanovic2005]\*\*
  - Spread in TCC is huge for only small deviations in test conditions
- Tools developed in literature
  - Are complex to use
  - Originate from different applications
- In this study: Test conditions similar to mechatronics applications
  - High precision systems  $\rightarrow$  in vacuum
  - Small contact areas  $\rightarrow$  dominant in heat transfer path
  - Relatively high contact pressures can be achieved
- \* [Incropera2006]: Fundamentals of heat and mass transfer, Incropera & DeWitt, 2006, 6th edition
- \*\* **[Yovanovic2005]**: Four Decades of Research on Thermal Contact, Gap, and Joint Resistance in Microelectronics, *M. Yovanovic, IEEE Trans. on components and packaging tech., vol. 28, 2005*
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contact pressure (Mpa)



### Objective

- Objective is to quantify the thermal contact conductance in vacuum
  - Meaning: a measure for the thermal coupling between surfaces in contact
  - No research on micro/macro-scopic contact in order to define general models
  - Test conditions as close to the conditions in High Precision Machines as possible
- Measure for thermal coupling
  - Expressed as a single heat transfer coefficient:  $h_{TCC}$  [W/m<sup>2</sup>K]
- Single parameter that quantifies the thermal coupling:

$$h_{TCC} = \frac{Q_{S1 \to S2}}{A_{con} \cdot (T_{s1} - T_{s2})}$$

- With
- $Q_{S1 \rightarrow S2}$ : Heat flow from Surface 1 to Surface 2 in [W]
- $-\ A_{con}$  the contact area between the solids in  $[m^2]$
- T<sub>S1</sub>: The surface averaged temperature of Surface 1 in [°C]
- T<sub>s2</sub>: The surface averaged temperature of Surface 2 in [°C]



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### Methodology





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#### Test settings

#### • Sample properties

- Materials investigated: Aluminum 5083 (Al5), Aluminum 6082 (Al6), AlSI316L (StSt), Titanium Grade 5 (Ti5)
- Contact surface roughnesses: Ra = 0.4 $\mu$ m (nominal), and Ra = 1.6, 3.2 and 6.4 $\mu$ m
- Contact sizes: 50mm<sup>2</sup> (contact pressure = 0.1 25MPa), 10mm<sup>2</sup> (contact pressure = 25 – 100MPa)
- Environmental conditions
  - Vacuum tests: air pressure: 1 5Pa air
  - Atmospheric tests: typical Dutch atmospheric pressure: 970 – 1050hPa air
  - Lab temperature: 20 24°C



### Procedure to determine $h_{TCC}$

Contact conductance is calculated via

 $-h_{TCC} = \frac{Q_{S1 \to S2}}{A_{con} \cdot (T_{S1} - T_{S2})}$ 

- Determination of  $Q_{th}$ 
  - Electrical input to heater is measured
  - Heat might leak to environment
  - Assumed heat flow through contact:  $Q_{S1 \rightarrow S2} = \alpha \cdot Q_{th}$
- Determination of A<sub>con</sub>
  - Test samples with  $A_{con} = 50 \text{mm}^2$  and with  $A_{con} = 10 \text{mm}^2$
  - Misalignment of samples leads to  $A_{con} = \beta \cdot A_{con}$
  - Maximal misalignment of 200µm between samples
- Determination of T<sub>S1</sub> and T<sub>S2</sub>
  - Measurement of NTCs is not at the contact
  - Model-based adjustment of the measurements needed
  - $T_{S1} = T_{NTC,top} R_{top} \cdot \alpha \cdot Q_{th}$
  - $T_{S2} = T_{NTC,btm} + R_{btm} \cdot \alpha \cdot Q_{th}$



- The adjustment parameters  $\alpha$ ,  $\beta$ ,  $R_{top}$  and  $R_{btm}$  are defined per sample pair
- The Contact Conductance can then be obtained via

$$h_{TCC} = \frac{\alpha \cdot Q_{th}}{\beta \cdot A_{con} \cdot \left(T_{NTC,top} - T_{NTC,btm} - \alpha \cdot Q_{th} (R_{top} + R_{btm})\right)}$$

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#### Thermal modelling Of part of the setup

- Thermal model set up in ANSYS Mechanical
  - Boundary conditions: heat sink, radiation, heat load
  - Contact between samples: h<sub>TCC</sub>
  - Other contacts:  $h_{con} \approx 1000 2000W/m^2K$  (subjected to full contact surface)
- Model used to determine the adjustment parameters  $\alpha$ ,  $\beta$ ,  $R_{top}$  and  $R_{btm}$  per sample pair
- Model used to define error budget:
  - Statistical sum of contributions: +/-20%



-	Error contribution	
Error source	50mm <sup>2</sup> contacts	
Heat load uncertainty due to voltage and current uncertainty	6.0%	
Heat flow uncertainty due to heat losses	10.0%	
Contact area uncertainty	3.2%	
NTC measurement error	2.5%	
Additional error due to temperature measurement adjustment		
Heat flow uncertainty	0.8%	
Misalignment	6.1%	
Uncertainty in thermal conductance	12.3%	
Uncertainty in emissivity samples	5.3%	
Uncertainty in emissivity heater top	5.4%	
Statistical sum:	20.2%	



#### Results

### Accuracy quantification

- Accuracy test: measure h<sub>TCC</sub> with glass plate between samples
- Effective HTC:
  - Conduction through glass:  $h_{eff} = 1000W/m^2K$
  - Contact Conductance AI to glass:  $h_{con} = 10000 W/m^2 K$
  - Total effective HTC:  $h_{eff} = \frac{1}{t/\lambda + 2/10000} = 833$  W/m<sup>2</sup>K
- Measurement
  - Al samples:  $h_{TCC}$  measured: 847W/m<sup>2</sup>K
  - StSt samples:  $h_{TCC}$  measured: 765W/m<sup>2</sup>K
- Conclusion: Measured  $h_{TCC}$  in line with expected  $h_{TCC}$



#### Results Nominal tests

- Nominal tests are employed with
  - Samples with a Ra of 0.4  $\mu m$
  - Contact pressure: 0.1 25MPa
- Observations
  - Some measurement points are not in line with the trend observed → this is assumed to be the nature of the TCC
  - TCC values for Al lie considerably higher than those for StSt and Ti
  - TCC for AI StSt not much higher than StSt StSt
- Correlations with literature
  - Good overlap with values from [Incropera2006]\* 10<sup>2</sup>
  - Good overlap with earlier found values in different test setup
  - Poor correlation with Yovanovic\*\* and FVV models\*\*\*



**\*** [Incropera2006]: Fundamentals of heat and mass transfer, *Incropera & DeWitt, 2006, 6th ed.* **\*\*** [Yovanovic2005]: Four Decades of Research on Thermal Contact, Gap, and Joint Resistance in Microelectronics, *M. Yovanovic, IEEE Trans. on components and packaging tech., vol. 28, 2005* **\*\*\*** [FVV2011]: Modellentwicklung für den kontaktdruckabhängigen ärmeübergang, *72.Jahrgang pp142-147, 2011*



#### Results High contact pressure

- High contact pressure tests are employed with
  - Samples with a Ra of 0.4 $\mu$ m
  - $A_{con} = 10 \text{mm}^2$
  - Contact pressure: 50 100MPa
- Observations •
  - TCC values seem to plateau towards an asymptotic value
  - Large variance between test with large contact surface and small contact surface @ 25MPa
- Correlations with literature
  - Poor correlation with Yovanovic model\*\*. but it is only valid up to 10MPa
  - Poor correlation with FVV models\*\*\* which are based on atmospheric tests and for >5 Recontacts



[Incropera2006]: Fundamentals of heat and mass transfer, Incropera & DeWitt, 2006, 6th ed. [Yovanovic2005]: Four Decades of Research on Thermal Contact, Gap, and Joint Resistance in Microelectronics, M. Yovanovic, IEEE Trans. on components and packaging tech., vol. 28, 2005 \*\*\* [FVV2011]: Modellentwicklung für den kontaktdruckabhängigen ärmeübergang, 72. Jahrgang pp142-147, 2011





#### Nominal tests Correlation with [Incropera2006]

- Nominal tests are employed with
  - Samples with a Ra of 0.4  $\mu m$
  - Contact pressure: 0.1 25MPa
- Correlations with literature
  - Good overlap with values from [Incropera2006]





#### Nominal tests Correlation with Yovanovic

- Nominal tests are employed with
  - Samples with a Ra of 0.4  $\mu m$
  - Contact pressure: 0.1 25MPa
- Correlations with literature
  - Poor correlation with Yovanovic and FVV models
  - Yovanovic model predicts significantly higher TCC values (up to one order of magnitude)
  - Models are used outside of their validity range
    - Surface roughness Ra < 3μm
    - Contact pressure > 10MPa
    - Aluminum samples



#### Nominal tests Correlation with FVV

- Nominal tests are employed with
  - Samples with a Ra of 0.4 $\mu$ m
  - Contact pressure: 0.1 25MPa
- Correlations with literature •
  - Poor correlation with Yovanovic and FVV models

h<sub>TCC</sub> [W/m<sup>2</sup>K]

10<sup>4</sup>

 $10^{3}$ 

 EVV models based on atmospheric tests





#### Results Re-contact tests

- Re-contact tests are employed with
  - Samples with a Ra of 0.4 and 1.6  $\mu m$
  - Contact pressure: 10MPa
- Observations
  - The AI AI contacts drop significantly after the first contact → due to changing surface conditions?
  - No real trend due to re-contacts can be determined
- Correlations with literature
  - In literature re-contacts are known to have an effect on the TCC value between surfaces





#### Conclusions & Future Work

### Conclusions



#### • Experimental Setup

- A test setup to measure the thermal contact conductance between metallic surfaces in vacuum is designed
- Measurement data is used together with model-based parameters to determine the h<sub>TCC</sub>
- An accuracy test with a known thermal resistance and model-based error budgeting establishes an accuracy of 20 and 30% for the 50mm<sup>2</sup> and 10mm<sup>2</sup> contacts, respectively
- General observation on the TCC value
  - The TCC of metallic surfaces is rather unpredictable and non-reproducible
  - Fresh Al Al contacts provide highest TCC values
  - AI AI contact conductance can significantly reduce when an oxidation layer has formed on the surfaces → the resulting h<sub>TCC</sub> is the same order of magnitude as those for StSt and Ti contacts
  - Comparison with TCC models from literature shows that very large mismatches can occur when models are used outside their validity range
- Advice for systems where performance is dominated by TCC behavior
  - Be aware of the large non-reproducibility that can occur upon recontact and/or changing surface conditions (e.g. oxidation)
  - Be aware of the validity ranges and quick deterioration outside these ranges of TCC models from literature
  - Do elaborate sensitivity studies on thermal models to investigate the impact of this
  - But if possible: Design such that performance is not impacted by changes in the TCC between surfaces



#### Future Work



- Currently we are continuing this study as part of an MSc-assignment
  - Reproducibility of test setup using glass plate
  - Experimentally qualifying heat losses in the setup
  - Surface topology investigation (using microscopes) to investigate changes in surface roughness/topology after re-contacts & their effect on the TCC value
- Research directions for future studies can be
  - Further investigate impact of orientation of surfaces on TCC
  - Investigate further combinations between materials and surface roughnesses
  - Investigate the use of fillers





#### Questions & Answers

**References:** 

- \* [Incropera2006]: Fundamentals of heat and mass transfer, Incropera & DeWitt, 2006, 6th ed.
- \*\* **[Yovanovic2005]**: Four Decades of Research on Thermal Contact, Gap, and Joint Resistance in Microelectronics, *M. Yovanovic, IEEE Trans. on components and packaging tech., vol. 28, 2005* \*\*\* **[FVV2011]**: Modellentwicklung für den kontaktdruckabhängigen ärmeübergang, *72.Jahrgang pp142-147, 2011*



### Thermal Contact Conductance



- Thermal Contact Conductance: the thermal resistance between two solids that are pressed together
- Typical order of magnitude
  - Highly variant under conditions, especially contact pressure
  - Low contact pressure (<1 Mpa):  $100 5000W/m^2K$
  - High contact pressure (>10MPa): 10 000 100 000W/m<sup>2</sup>K
- In high precision applications
  - Often vacuum
  - Small contact areas  $\rightarrow$  dominant in heat transfer path
  - Relatively high contact pressures can be achieved



#### Thermal Contact Conductance; [Incropera2006]

\* [Incropera2006]: Fundamentals of heat and mass transfer, Incropera & DeWitt, 2006, 6th edition

### Motivation

- Thermal Contact Conductance (TCC) in vacuum
  - High precision systems  $\rightarrow$  in vacuum
  - Dominant phenomenon in thermal modelling
- TCC has been addressed in literature
  - Overview presented in [Yovanovic2005]\*\*
  - Multiple application areas
  - Spread in TCC is huge for only small deviations in test conditions
- Tools developed in literature
  - Are complex to use
  - Originate from different applications
- In this study:
  - Vacuum conditions
  - Test conditions similar to mechatronics applications

\*\* **[Yovanovic2005]**: Four Decades of Research on Thermal Contact, Gap, and Joint Resistance in Microelectronics, *M. Yovanovic, IEEE Trans. on components and packaging tech., vol. 28, 2005* 







#### Experimental Setup Some Pictures







#### Experimental Setup Some Pictures











### Determined adjustment parameters



- The adjustment parameters  $\alpha,\,\beta,\,R_{top}$  and  $R_{btm}$  are defined per sample pair

Sample combination	Contact area [mm <sup>2</sup> ]	Contact pres. [MPa]	Percentage of heat input used: α [ – ]	Percentage of contact area used: β [ – ]	R <sub>top</sub> [K/W]	R <sub>btm</sub> [K/W]
Al5 – Al5	50	0 – 25	1.0	1.0	0.19	0.18
Al6 – Al6	50	0 – 25	1.0	1.0	0.13	0.13
StSt – StSt	50	0 – 25	0.975	1.0	1.36	1.31
Ti5 – Ti5	50	0 - 5	0.90	1.0	3.27	3.17
Ti5 – Ti5	50	6 – 25	0.95	1.0	3.24	3.15
Al5 – Al5	10	25 – 100	1.0	0.95	0.56	0.56
StSt – StSt	10	25 – 100	0.90	0.95	4.14	4.13
Ti5 – Ti5	10	25 – 100	0.85	0.95	9.42	9.42
Al – StSt	50	0 – 25	1.0	1.0	Al5: 0.19 Al6: 0.13 StSt: 1.30	Al5: 0.18 Al6: 0.13 StSt: 1.30

#### Error Budget

- Types of erros:
  - Physical errors between measured quantity and actual quantity: heat flow, contact area, etc
  - Model errors between
- Magnitude of errors is determined via model and measurement equipment accuracy

<b>F</b>	Error contribution		
Error source	Large contacts	Small contacts	
Heat load uncertainty due to voltage and current uncertainty	6.0%	6.0%	
Heat flow uncertainty due to heat losses	10.0%	12%	
Contact area uncertainty	3.2%	5%	
NTC measurement error	2.5%	1.2%	
Additional error due to temperature measurement adjustment			
Heat flow uncertainty	0.8%	2.9%	
Misalignment	6.1%	12.1%	
Uncertainty in thermal conductance	12.3%	13.1%	
Uncertainty in emissivity samples	5.3%	15.1%	
Uncertainty in emissivity heater top	5.4%	16.0%	
Statistical sum:	20.2%	31.9%	





#### Results Surface roughness tests

- Surface roughness tests are employed with
  - Samples with a Ra of 1.6, 3.2 and 6.4 $\mu m$
  - Contact pressure: 0.1 25MPa
- Observations
  - At small contact pressures the TCC value can increase with surface roughness
  - Generally (at higher contact pressures) the TCC value drops for higher surface roughness and settles at some asymptote beyond 3µm
- Correlations with literature
  - Same qualitative behavior observed as in literature where rougher surfaces have a higher TCC at low contact pressures



# Accuracy quantification Aluminum samples

- Accuracy test: measure h<sub>TCC</sub> with glass plate between samples
- Theoretical HTC:
  - Glass plate properties: Thickness: t = 1.09mm, Conductivity:  $\lambda$  = 1.09W/mK
  - Contact Conductance AI to glass:  $h_{con} = 10000 W/m^2 K$
  - Total effective HTC:  $h_{eff} = \frac{1}{t/\lambda + 2/10000} = 833$  W/m<sup>2</sup>K
- Measurement
  - $\alpha$  determined model-based: 0.925
  - $-~\beta,\,R_{top}$  and  $R_{btm}$  as determined for Al samples
  - Contact pressure = 10MPa
  - Heater power:  $Q_{th} = 1.02W$
  - dT measured: 22.63K
  - dT corrected: 22.28K
  - $-h_{TCC}$  measured: 847W/m<sup>2</sup>K
- Conclusion: Measured  $h_{TCC}$  in line with expected  $h_{TCC}$



# Accuracy quantification StSt samples

- Accuracy test: measure h<sub>TCC</sub> with glass plate between samples
- Theoretical HTC:
  - Glass plate properties: Thickness: t = 1.09mm, Conductivity:  $\lambda$  = 1.09W/mK
  - Contact Conductance AI to glass:  $h_{con} = 10000 W/m^2 K$
  - Total effective HTC:  $h_{eff} = \frac{1}{t/\lambda + 2/10000} = 833$  W/m<sup>2</sup>K
- Measurement
  - $\alpha$  determined model-based: 0.925
  - $-~\beta,\,R_{top}$  and  $R_{btm}$  as determined for StSt samples
  - Contact pressure = 10MPa
  - Heater power:  $Q_{th} = 0.961W$
  - dT measured: 25.60K
  - dT corrected: 23.23K
  - $-h_{TCC}$  measured: 765W/m<sup>2</sup>K
- Conclusion: Measured  $h_{TCC}$  10% lower than expected  $h_{TCC}$

